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AF/1762
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Chen, et al.

Serial No.: 10/052,049

Confirmation No.: 1518

Filed: January 16, 2002

For: Method for Growing Thin
Films by Catalytic
Enhancement

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Group Art Unit: 1762

Examiner: Timothy H. Meeks

CERTIFICATE OF MAILING
37 CFR 1.8

Dear Sir:

RESPONSE TO FINAL OFFICE ACTION DATED APRIL 8, 2004

In response to the Final Office Action dated April 8, 2004, having a shortened statutory period for response set to expire on June 8, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5027/KMT, the amount of \$110.00, for a statutory disclaimer fee, along with any other fees to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 6 of this paper.